



Docket No. 740819-418

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Kazuichiro ITOHADA et al.

Serial No. 09/862,004

Filed: September 14, 2000

For: "METHOD OF FORMING
INSULATING FILM AND METHOD
OF FABRICATING
SEMICONDUCTOR DEVICE"

-)
-) Group Art Unit: 2823
-) Examiner: William M. Brewster
-) Confirmation No. 9057
-) Date: June 10, 2003

#11/A

Amend

Immunization
6/19/03

CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to: Mail Stop Fee Amendments, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, on June 10, 2003.

Signature:

Name: Linda C. Haynes

AMENDMENT

Mail Stop Fee Amendments
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed January 10, 2003, the due date for which having been extended two (2) months to June 10, 2003, please consider the remarks and amendments in connection with the above-identified application.

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